

ATTORNEY DOCKET
064747.1017

PATENT APPLICATION
10/825,021

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Shannon V. Davidson et al.
Serial No.: 10/825,021
Filing Date: April 15, 2004
Group Art Unit: 2191
Confirmation No.: 7500
Title: *System and Method for Topology-Aware Job Scheduling and Backfilling in an HPC Environment*

Mail Stop: Amendments
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

Information Disclosure Statement

Applicants submit this Information Disclosure Statement (IDS) under 37 C.F.R. § 1.97(b)(3). Applicants respectfully request the Examiner to consider and cite in the examination of this Application the documents listed in the attached Form PTO-1449. Under 37 C.F.R. § 1.98(a)(2)(ii), Applicants have provided copies of all references other than U.S. patents and U.S. patent application publications.

The Commissioner is hereby authorized to charge any fee and credit any overpayment to Deposit Account No. 02-0384 of Baker Botts L.L.P.

Respectfully submitted,
BAKER BOTTS L.L.P.
Attorneys for Applicants



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Date: March 2, 2007

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Customer Number 45507

PTO-1449 Information Disclosure Citation In an Application			Application No. 10/825,021		Applicant(s) Shannon V. Davidson et al.		
			Docket Number 064747.1017		Group Art Unit 2191		Filing Date April 15, 2004
U.S. PATENT DOCUMENTS							
		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES NO
NON-PATENT DOCUMENTS							
		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)					DATE
	A	Hans-Ulrich Heiss, "Processor Management in Two-Dimensional Grid-Architectures," Interner Bericht Nr. 20/92, XP002416087, 51 pages					December 1992
	B	EPO Registered Letter, Application No. 05 252 239.8-1243, 6 pages					Mailed 02/02/2007
	C						
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	M						
EXAMINER				DATE CONSIDERED			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							

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